



## PATENT APPLICATION

## **RESPONSE UNDER 37 CFR §1.116 EXPEDITED PROCEDURE TECHNOLOGY CENTER ART UNIT 2828**

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Daniel KOPF et al.

Group Art Unit: 2828

Application No.: 10/006,396

Examiner:

D. Nguyen

Filed: December 10, 2001

Docket No.:

111399

For:

HIGH POWER AND HIGH GAIN SATURATION DIODE PUMPED LASER MEANS

AND DIODE ARRAY PUMPING DEVICE

## **AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR §1.116**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In reply to the March 10, 2004 Final Rejection, the period for response having been extended by the attached Petition for Extension of Time, please consider the following:

Amendments to the Claims as reflected in the listing of claims; and Remarks.